

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Basol et al.
App. No : 10/782,697
Filed : February 18, 2004
For : METHOD OF WAFER PROCESSING
WITH EDGE SEED LAYER
REMOVAL
Examiner : Michael Manh Trinh
Art Unit : 2822
Conf # : 5582

CERTIFICATE OF EFS WEB
TRANSMISSION

I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

September 26, 2007

(Date)



Adam Gilbert, Reg. No. 59,967

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION DATED JULY 6, 2007**Mail Stop RCE**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated July 6, 2007, the Applicants respectfully request that the Examiner reconsider the above-identified patent application in view of the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.